



SUGHRUE MION, PLLC

2100 Pennsylvania Avenue, NW
Washington, DC 20037-3213

T 202.293.7060
F 202.293.7860

www.sughrue.com

July 30, 2003

MAIL STOP PATENT APPLICATION

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Re: Application of Fujio AKAHANE, Nagamitsu TAKASHIMA, Kazushige
HAKEDA and Ryoji UESUGI
METHOD OF PUNCHING SMALL HOLE AND METHOD OF
MANUFACTURING LIQUID EJECTION HEAD USING THE SAME
Assignee: SEIKO EPSON CORPORATION
Our Ref. Q76765

Dear Sir:

Attached hereto is the application identified above comprising fifty-three (53) sheets of the specification, including the claims and abstract and fifteen (15) sheets of drawings. **The requisite U.S. Government Filing Fee, executed Declaration and Power of Attorney and Assignment will be submitted at a later date.**

The Government filing fee is calculated as follows:

Total claims	<u>29</u> - 20	= <u>9</u>	x	\$18.00	=	<u>\$162.00</u>
Independent claims	<u>2</u> - 3	=		x	\$84.00	= <u>\$0.00</u>
Base Fee						\$750.00
TOTAL FEE						<u>\$912.00</u>

Priority is claimed from:

<u>Country</u>	<u>Application No</u>	<u>Filing Date</u>
Japan	2002-221996	July 30, 2002
Japan	2003-203106	July 29, 2003

The priority documents will be filed at a later date.

Respectfully submitted,
SUGHRUE MION, PLLC

Attorneys for Applicant

By: *Darryl Mexic*
Darryl Mexic
Registration No. 23,063

SUGHRUE MION, PLLC
Telephone: (202) 293-7060
Facsimile: (202) 293-7860

WASHINGTON OFFICE

23373

CUSTOMER NUMBER